

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Patent No. 7,166,539 B2
Patent Issue Date January 23, 2007
Application Serial No. 10/625,166
Filing Date July 22, 2003
Assignee Micron Technology, Inc.
Inventorship Janos Fucsko et al.
Attorney's Docket No. MI22-2246
Title: Wet Etching Method of Removing Silicon From a Substrate

REQUEST FOR CERTIFICATE OF CORRECTION OF PATENT
FOR PTO MISTAKE (37 C.F.R. 1.322(a))

To: Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

ATTN: Decision and Certificate of Correction
Branch of the Patent Issue Division

From: Mark S. Matkin (Tel. 509-624-4276; Fax 509-838-3424)
Wells St. John P.S.
601 W. First Avenue, Suite 1300
Spokane, WA 99201-3828

Sir:

It is hereby requested that a Certificate of Correction be issued with respect to Patent No. 7,166,539 B2, granted January 23, 2007, in accordance with the Certificate of Correction form attached hereto.

The errors listed on the Certificate of Correction form were apparently incurred through the fault of the PTO as will be disclosed by the records of files in the Office.

Since this Certificate of Correction is being requested due to PTO errors, it is believed that no fee is due. However, in the event that a fee is required for issuance of this Certificate of Correction, please charge the fee specified under 37 C.F.R. § 1.20(a) to Deposit Account No. 23-0925. Please credit Deposit Account No. 23-0925 with any overpayment of the above fee.

Attached hereto, is Form PTO-1050, being suitable for printing.

Respectfully submitted,

Dated: 7-21-07

By:



Mark S. Matkin
Reg. No. 32,268

UNITED STATES PATENT AND TRADEMARK OFFICE
CERTIFICATE OF CORRECTION

PATENT NO. : 7,166,539 B2
DATED : January 23, 2007
INVENTOR(S) : Fucsko et al.

It is certified that errors appear in the above-identified patent and that said Letters Patent is hereby corrected as shown below:

Col. 6, line 30, claim 9, please delete "cleionized" before "water" and insert --deionized--.

Col. 8, line 16, claim 44, please delete "silicon-selectively" after "elemental" and insert --silicon selectively--.

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Mailing Address of Sender: Mark S. Matkin Wells St. John P.S. 601 West First Avenue, Suite 1300 Spokane, WA 99201-3828	Patent No. <u>7,166,539 B2</u>
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